JAN 1 5 2004 W

Docket No.: 50212-535 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Yoshiki NISHIBAYASHI, et al. : Confirmation Number: 8079

Serial No.: 10/661,591 : Group Art Unit: 1765

Filed: September 15, 2003 : Examiner: Unknown

For: MICROFABRICATED DIAMOND ELEMENT AND METHOD OF FABRICATING

MICROFABRICATED DIAMOND ELEMENT

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of the references listed on attached Form 1449 is discussed in the present specification.

10/661,591

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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Facsimile: (202) 756-8087 **Date: January 15, 2004**

INFO	CIT	TAT	ON DISCLOS ION IN AN ICATION	SURE	ATTY. DOCKET NO. 50212-535		SERIAL NO. 10/661,591			
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1				U.S. PATE	NT DOCUMENTS					
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			JP P2002-75171A	03/15/2002	JAPAN FINE CERAMICS CENTER SUMITOMO ELECTRIC IND LTD			(Japan w/English Abstract)		
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			New Diamond (Japan New Diamond Forum) Vol. 17, No. 4 (2001) p. 14-15, 5-1							
		Extended Abstracts (The 47th Spring Meeting); The Japan Society of Applied Physics and Related Societies, No. 1 30a-YQ-3 (p. 377)								
		Extended Abstracts (The 46th Spring Meeting); The Japan Society of Applied Physics and Related Societies, No. 1 30p-M- 12 (p. 415)								
		Extended Abstracts (The 62nd Autumn Meeting); The Japan Society of Applied Physics and Related Societies, No. 3 13a-ZK-5 (p. 782)								
EXAMINER						DATE CONSIDERED				

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.